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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Akif Sultan et al.

Serial No.: 10/790,939

Filed: March 1, 2004

For: BI-MODAL HALO
IMPLANTATION

§ Group No.:

§

§ Examiner:

§

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§ Atty. Dkt. No.: AMDI:133\HON
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CERTIFICATE OF MAILING 37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date below:

May 21, 2004

Date



Timothy M. Honeycutt

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. 1.97(b)(1) AND 1.98**

In compliance with the duty of disclosure under 37 C.F.R. 1.56(a), Applicants respectfully request that this Information Disclosure Statement be entered and that the reference(s) listed in the form PTO-1449 filed concurrently herewith be considered by the Examiner and made of record. Copies of any non-U.S. patent references listed in the accompanying form PTO-1449 are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made, as an admission that the information cited in the accompanying form PTO-1449 is, or is considered to be, material to patentability as defined in 37 C.F.R. 1.56(b), or as a representation that no other possibly material information, as defined in 37 C.F.R. 1.56(b), exists.

The information is listed in the accompanying form PTO-1449 in accordance with 37 C.F.R. 1.98. Any explanation of non-English language documents cited in the accompanying form PTO-1449 is believed to constitute a concise explanation of the relevance of the listed reference(s) as they are presently understood by the individual designated in 37 C.F.R. 1.56(c) most knowledgeable about the content of the listed reference(s), in accordance with 37 C.F.R. 1.98(a)(3).

RELATED APPLICATION

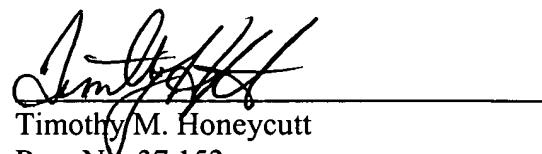
In addition to the above-listed references, Applicants bring to the Examiner's attention the following pending U.S. application: Ser. No. 10/693,016; filed October 24, 2003.

MISCELLANEOUS

The Commissioner is authorized to charge any required fees or credit any overpayment to Deposit Account No. 01-0365, Order No. AMDI:133\HON.

Respectfully submitted,

Date: May 21, 2004



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Advanced Micro Devices, Inc.



PTO-1449 (modified)

List of Patents and Publications
For Applicant's Information
Disclosure Statement
(Use several sheets if necessary)

ATTY. DOCKET NO. AMDI:133HON	SERIAL NO. 10/790,939
APPLICANT Akif Sultan et al.	CERTIFICATE OF MAILING 37 C.F.R. 1.8 I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on the date below: <i>May 21, 2004</i> <i>Timothy M. Honeycutt</i> Date: _____ Signature: _____ Timothy M. Honeycutt
FILING DATE March 1, 2004	GROUP

U.S. PATENT DOCUMENTS

EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	A1	6,114,211	September 5, 2000	H. Jim Fulford et al.	448	305	
	A2	5,227,321	July 13, 1993	Ruoja Lee et al.	437	44	
	A3	10/693,016		Scott Goad et al.			October 24, 2003

FOREIGN PATENT DOCUMENTS

EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION

OTHER ART

EXAM INIT.	REF. DES.	AUTHOR; TITLE; JOURNAL; VOLUME; DATE; PERTINENT PAGES
	A4	Stanley Wolf and Richard N. Tauber; <i>Silicon Processing for the VLSI Era, Volume 3 - The Submicron MOSFET</i> ; pp.226-232, 240, 309-311 and 621-622; 1995
	A5	Terence B. Hook et al.; <i>High-Performance Logic and High-Gain Analog CMOS Transistors Formed by a Shadow-Mask Technique With a Single Implant Step</i> ; IEEE Transactions on Electron Devices, Vol. 49, No. 9, September 2002; pp. 1623-1627

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement--PTO-1449 (Modified)